IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re P	atent Ap	olication of:	
Koji SI	HIGEMUI	RA, et al.	
Application No.:			Group Art Unit:
Filed:	Novemb	per 24, 2003	Examiner:
For:	ELECT	The state of the s	D OF FABRICATING ORGANIC CE USING THE SAME, AND ORGANIC CE
		INFORMATIO	N DISCLOSURE STATEMENT
PO Bo	x 1450	for Patents 22313-1450	
Sir:			
subjec	ed certaiı t U.S. pa	n information which the E tent application. It is req	sclosure provisions of 37 CFR § 1.56, there is hereby xaminer may consider material to the examination of the uested that the Examiner make this information of record on of the subject application.
	1. I	Enclosures accompanyin	g this Information Disclosure Statement are:
	1a. 1b. 1c. 1d. 1e.	Copies of IDS citation An English language application or a PC English language transported each non-English language transported to Explanations of Rel	e copy of search report(s) from a counterpart foreign I International Search Report. anslation (complete or relevant portion(s)) attached to
	2. 🗌		FR § 1.98, a concise explanation of what is presently evance of each non-English language publication is
	2a.	satisfied because al enclosed "English-la indicates the degree 609, Minimum Requ A(3): Concise Expla Feb. 2000.)	priate Items 2a, 2b, 2c and/or 2d) I non-English language publications were cited on the anguage version of the search report or action which of relevance found by the foreign office". (See MPEP direments for an Information Disclosure Statement, Part nation of Relevance, pp. 600-100 to 600-101, Rev. 1,
	2b.	set forth in the appli	cauon.

	n English language translation (complete or relevant ed to each non-English language publication. ment 1(e), hereto.
to be, material to patentabilit (other than search report(s)	ne information cited in this Statement is, or is considered y nor a representation that a search has been made from a counterpart foreign application or a PCT if submitted herewith). 37 CFR §§ 1.97(g) and (h).
	Respectfully submitted,
	STAAS & HALSEY LLP
Dated: November 24, 2003 1201 New York Ave., N.W., Suite 700 Washington, D.C. 20005	By: Michael D. Stein Registration No. 37,240
Telephone: (202) 434-1500	

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FORM PTO-1449

U.S. DEPARTMENT OF COMMERCE

ATTORNEY DOCKET NO. 1670.1019

APPLICATION NO.

PATENT AND TRADEMARK OFFICE

FIRST NAMED INVENTOR

Koji SHIGEMURA, et al.

FILING DATE

GROUP ART UNIT

LIST OF REFERENCES CITED BY APPLICANT

(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
	AA						
	АВ						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB- CLASS	TRANS	ATION NO
	AC	2001-247961	9-14-01	Japanese				Х
	AC	2001-273979	10-5-01	Japanese				Х
,	AE	2001-254169	9-18-01	Japanese				Х
	AF	2002-9098	1-11-02	Japanese				X
	AG	2002-8859	1-11-02	Japanese				X
	АН	2000-48954	2-18-00	Japanese				Х
	AI	2000-173769	6-23-00	Japanese				X
	AJ	2001-203079	7-27-01	Japanese				Х
	AK	2001-110567	4-20-01	Japanese				Х

OTHER REFERENCES (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)

AM	
AN	
AO	

EXAMINER	DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

ATTACHMENT 1(e)

OF REFERENCES

ATTORNEY DOCKET NO.	APPLICATION NO.
1670.1019	
1070.1015	
FIRST NAMED INVENTOR	
Koji SHIGEMURA, et al.	
rtoji or irozwiora t, ot al.	
FILING DATE	GROUP ART UNIT

Reference AC: Japanese Publication No. 2001-247961, published 9-14-01, is generally related to "EVAPORATION MASK, METHOD OF FABRICATING ELECTROLUMINESCENT DEVICE USING THE SAME, AND ORGANIC ELECTROLUMINESCENT DEVICE"

Reference AD: Japanese Publication No. 2001-273979, published 10-5-01, is generally related to "EVAPORATION MASK, METHOD OF FABRICATING ELECTROLUMINESCENT DEVICE"

Reference AE: Japanese Publication No. 2001-254169, published 9-18-01, is generally related to "EVAPORATION MASK, METHOD OF FABRICATING ELECTROLUMINESCENT DEVICE"

Reference AF: Japanese Publication No. 2002-9098, published 1-11-02, is generally related to "EVAPORATION MASK, METHOD OF FABRICATING ELECTROLUMINESCENT DEVICE USING THE SAME, AND ORGANIC ELECTROLUMINESCENT DEVICE"

Reference AG: Japanese Publication No. 2002-8859, published 1-11-02, is generally related to "EVAPORATION MASK, METHOD OF FABRICATING ELECTROLUMINESCENT DEVICE"

Reference AH: Japanese Publication No. 2000-48954, published 2-18-00, is generally related to "EVAPORATION MASK, METHOD OF FABRICATING ELECTROLUMINESCENT DEVICE"

Reference AI: Japanese Publication No. 2000-173769, published 6-23-00, is generally related to "EVAPORATION MASK, METHOD OF FABRICATING ELECTROLUMINESCENT DEVICE USING THE SAME, AND ORGANIC ELECTROLUMINESCENT DEVICE"

Reference AJ: Japanese Publication No. 2001-203079, published 7-27-01, is generally related to "EVAPORATION MASK, METHOD OF FABRICATING ELECTROLUMINESCENT DEVICE USING THE SAME, AND ORGANIC ELECTROLUMINESCENT DEVICE"

Reference AK: Japanese Publication No. 2001-110567, published 4-20-01, is generally related to "EVAPORATION MASK, METHOD OF FABRICATING ELECTROLUMINESCENT DEVICE"